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Docket No.: TLO-2-PCT/US/Minori

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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April 2, 2007  
(date)

*Lori G. Witkin*  
Lori G. Witkin

In re: Application of: Tetsuro TAKAMATSU, et al.

Serial No. : 10/540,600 Group Art Unit: 2874

Filed : June 24, 2005 Examiner: T. Wong

For : MULTILAYER OBSERVATION OPTICAL MICROSCOPE  
AND MULTILAYER OBSERVATION UNIT

New York, New York  
April 2, 2007

**REQUEST FOR RECONSIDERATION**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated January 3, 2007, reconsideration of the outstanding rejections is respectfully requested in view of the remarks beginning on page 2 herein, please amend this patent application as follows: